

11/30/2006 15:03

==== COVER SHEET ===

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FROM: MCKENNA LONG ALDRIDG

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COMMENT:

PAGE 1/9 * RCVD AT 11/30/2006 3:03:09 PM [Eastern Standard Time] * SVR:USPTO-EFXRF-5/6 * DNIS:2731389 * CSID:202 496 7756 * DURATION (mm:ss):01:26

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Date: November 30, 2006

To:

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Examiner Stephen D. Rosasco U.S. Patent and Trademark Office (Art Unit 1756)	(571) 273-1389	(571) 272-1389

From: Jeanne A. Di Grazio/es **Phone:** (202) 496-7309

Re: U.S. Application Serial No. 10/705,891

Number of Pages (including cover): 8

Message:

U.S. Application Serial No. 10/705,891

Filed: November 13, 2003

Title: MASK FOR LASER IRRADIATION AND APPARATUS FOR LASER CRYSTALLIZATION USING THE SAME

Inventor(s): Yun Ho JUNG

Examiner Rosasco:

Per our previous telephone call, please find the attached courtesy copy of the Supplemental Amendment which was filed today in connection with the above referenced application.

User No.	4091	Client/Matter No.:	08734.0254
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Docket No.: 8734.254.00-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yun Ho JUNG

Customer No.: 30827

Application No.: 10/705,891

Confirmation No.: 6104

Filed: November 13, 2003

Art Unit: 1756

For: MASK FOR LASER IRRADIATION AND
APPARATUS FOR LASER
CRYSTALLIZATION USING THE SAME

Examiner: Stephen D. Rosasco

MS Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL AMENDMENT

Sir:

Further to the Amendment filed on October 27, 2006 in response to the Office Action dated July 28, 2006, please amend the above-identified Patent Application as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.